



Docket No.: 007733 USA/FPS/MMCS/APC
0107262.00181US1
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Alexander T. SCHWARM Confirmation No.: 2673
Application No.: 10/765,921 Art Unit: 2125
Filed: January 29, 2004 Examiner: S. P. Shechtman
Title: SYSTEM, METHOD, AND MEDIUM FOR MONITORING
PERFORMANCE OF AN ADVANCED PROCESS CONTROL
SYSTEM

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REPLY AND REQUEST FOR CONTINUED EXAMINATION UNDER 37 CFR 1.114

Dear Sir:

INTRODUCTORY COMMENTS

This amendment, along with a request for continued examination, is being filed in response to the final Office Action mailed on April 12, 2007. Applicants enclose the appropriate fee in accordance with 37 C.F.R. § 1.17(e). Please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 31 of this paper.